

Inventor: Paul A. Farrar

Title: Digital Data Apparatuses and Digital Data Operational Methods

Assignee: Micron Technology, Inc.

INFORMATION DISCLOSURE STATEMENT

References – See Attached Form PTO-1449


The attached form PTO-1449 is submitted in compliance with 37 CFR § 1.56. Copies of the cited art are included. No admission is made regarding whether all the submitted references are prior art.

Respectfully submitted,

Dated:

10/17/03

By:


James D. Shaurette
Reg. No. 39,833

EL979977585

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-2054		SERIAL NO. Filed Herewith	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Paul A. Farrar			
				FILING DATE Filed Herewith		GROUP Unknown	
U.S. PATENT DOCUMENTS							
*Examiner Initial		Document Number	Date	Name	Class	Subclasses	Filing Date If Appropriate
	AA	5,920,785	7/6/1999	Chi et al.			
	AB	6,184,548 B1	2/6/2001	Chi et al.			
	AC	3,387,282	6/4/1968	Jaques, J.O.			
	AD	US 2002/0009874	1/24/2002	Farrar et al.			
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	AL						
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclasses	Translation
							Yes No
	AM						
	AN						
	AO						
	AP						
	AQ						
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
	AR		*SEMICONDUCTORS: IBM, Infineon Open Trench Warfare Over 1-Gbit Design;" Anthony Cataldo; http://www.eetimes.com/semi/news/OEG19991028S0038 ; October 28, 1999; 5 pps.				
	AS		"A Novel Trench DRAM Cell with a VERTICAL Access Transistor and BuriEd STRap (VERY BEST) for 4GB/16Gb;" U. Gruening, C.J. Radens, J.A. Mandelman, A. Michaelis, M. Seitz, N. Arnold, D. Lea, D. Casarotto, A. Knorr, S. Halle, T.H. Ivers, L. Economikos, S. Kudelka, S. Raha, H. Tews, H. Lee, R. Divakaruni, J.J. Welser, T. Furukawa, T. S. Kanarsky, J. Alsmeier, G. B. Bronner; printed September, 1999; 4 pps.				
EXAMINER				DATE CONSIDERED			
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							